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Information Disclosure Statement					APPLICANT Akinobu Sato, et al.				
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Initial	No.	journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), pu				for country where published.	YES	NO	
		Yamada, "Cluster ion beam process technology – 20 years of R&D history", Nuclear Instruments and Methods in Physics Research, B257, 2007, pp.632-638.					Eng		
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